							ocket No.
AMENDMENT TRANSMITTAL LETTER						02008/071003	
Application No.		Filing Date			Examiner		Art Unit
10/779,904-Conf. #9608		February 17, 2004		Not Yet Assigne		ned	2136
Applicant(s): Masahiro Ishida et al.							
Invention: METHOD AND APPARATUS FOR DEFECT ANALYSIS OF SEMICONDUCTOR INTEGRATED CIRCUIT							
TO THE COMMISSIONER FOR PATENTS							
Transmitted herewith is an amendment in the above-identified application.							
The fee has been calculated and is transmitted as shown below.							
CLAIMS AS AMENDED							
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present		Rate		
Total Claims	3	- 20 =	0	Х	52.00		0.00
Independent Claims	3	- 3 =	0	х	220.00		0.00
Multiple Dependent Claims (check if applicable)							
Other fee (please specify):							
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:							0.00
x Large Entity Small Entity							
No additional fee is required for this amendment.							
Please charge Deposit Account No in the amount of \$ A duplicate copy of this sheet is enclosed.							
A check in the amount of \$ to cover the filing fee is enclosed.							
Payment by credit card. Form PTO-2038 is attached.							
The Director is hereby authorized to charge and credit Deposit Account No							
x Credit any overpayment.							
x Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.							
Dated: October 31, 2008							31, 2008
Thomas K. Sch					· · · · · · · · · · · · · · · · · · ·		
Attorney/Agent	Reg. No.: 45,	079					
OSHA · LIANG LLP							
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(713) 228-8600							